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INFO	KMAHON	וטי	SCLOSURE	Filing Date	November 26, 2003	
STA	TEMENT B	Y A	APPLICANT	First Named Inventor	Shih-Jong J. Lee	
,				Art Unit		
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Sheet	1	of	2	Attorney Docket Number	SV31	

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Examiner Initials		Document Number Number - Kind Code <sup>2</sup> (if known	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear		
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FOREIGN PATENT DOCUMENTS								
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INFOR	CIVIA HON L	JIS	CLOSURE	Filing Date	November 26, 2003	
STATI	EMENT RY	΄ Δ	PPLICANT	First Named Inventor	Shih-Jona J. Lee	
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/NB/ subpixel registration" Proc. SPIE Vol. 1989, p. 50-59, Computer Vision for	Features Based on Paraboloid Surface fit", SPIE Vol. 1386. Machine Vision						
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